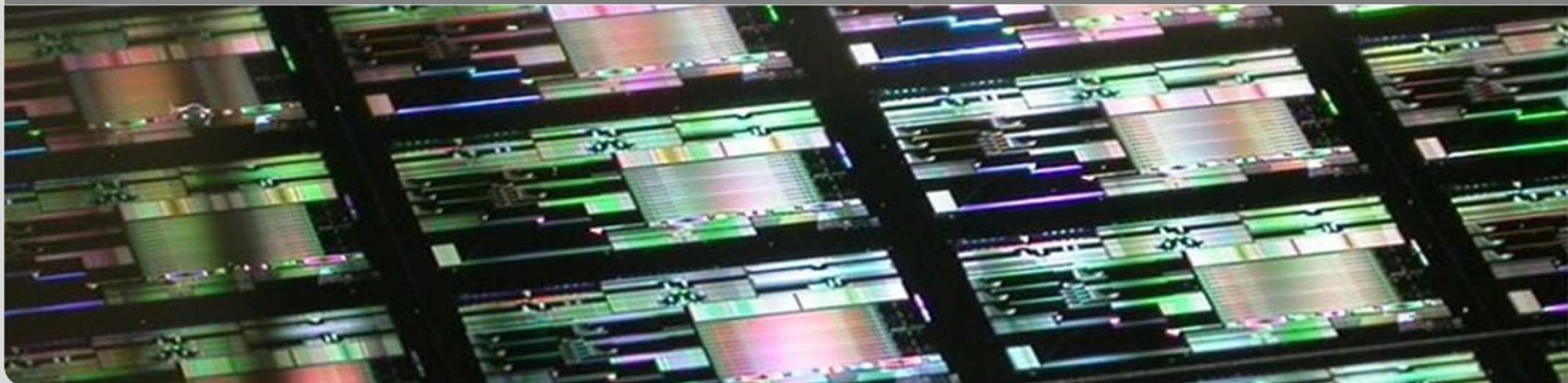


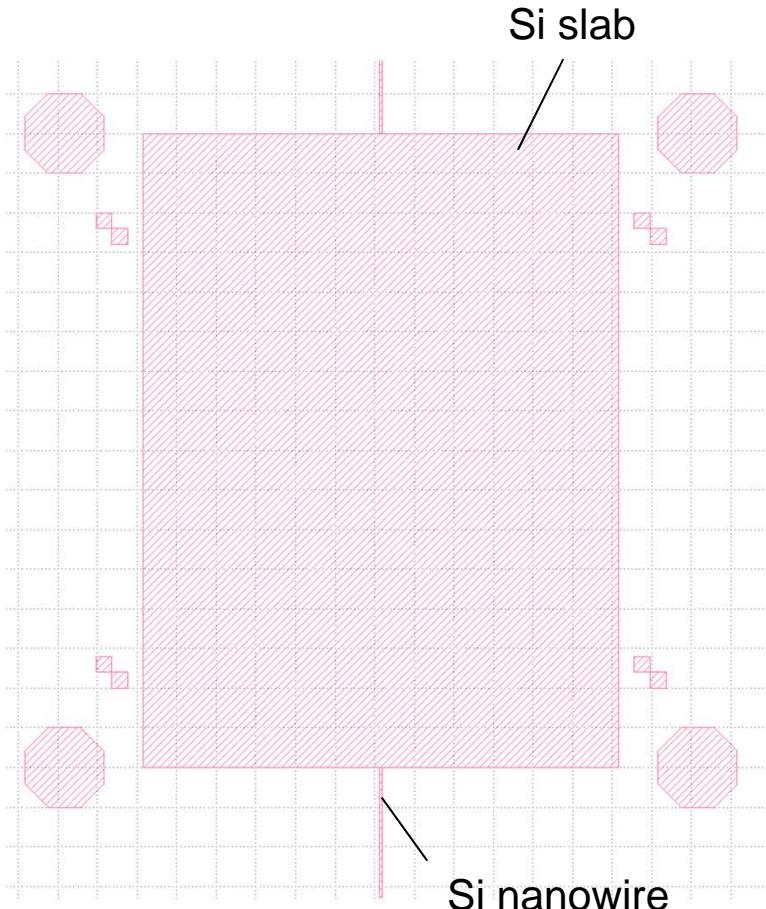
## NAVOLCHI TeleConf. 03.09.2012

Institute of Photonics and Quantum Electronics (IPQ), Karlsruhe, Germany  
Institute of Microstructural Technology, Karlsruhe, Germany

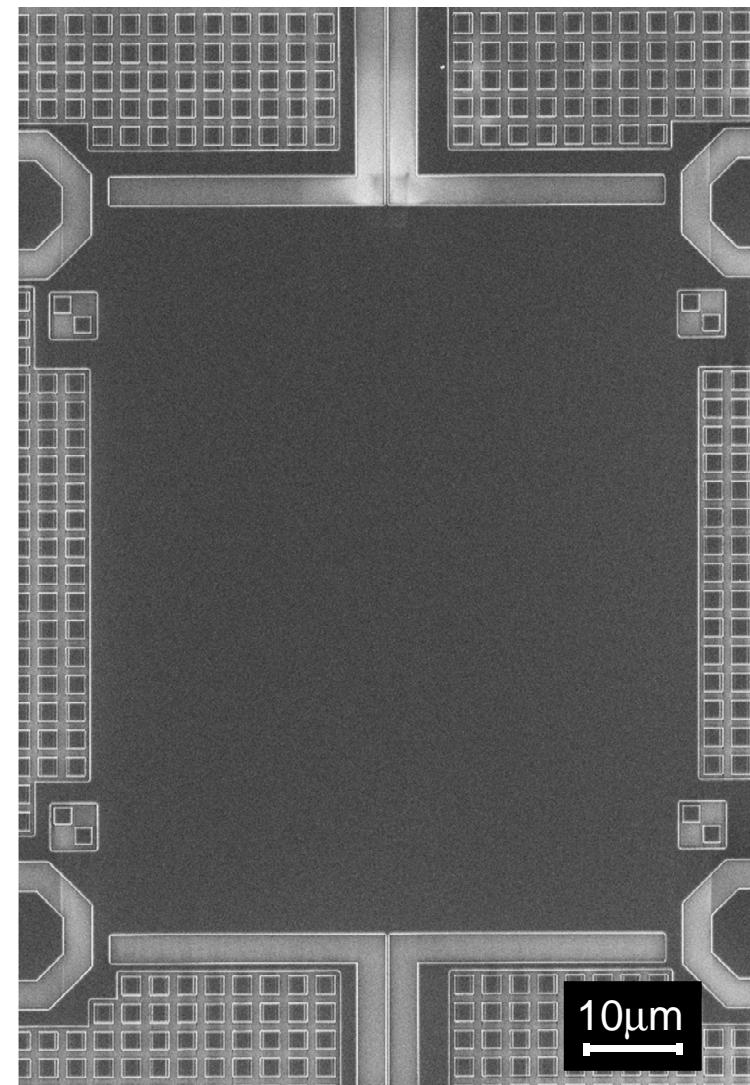


# Current Activities / from last TelConf.

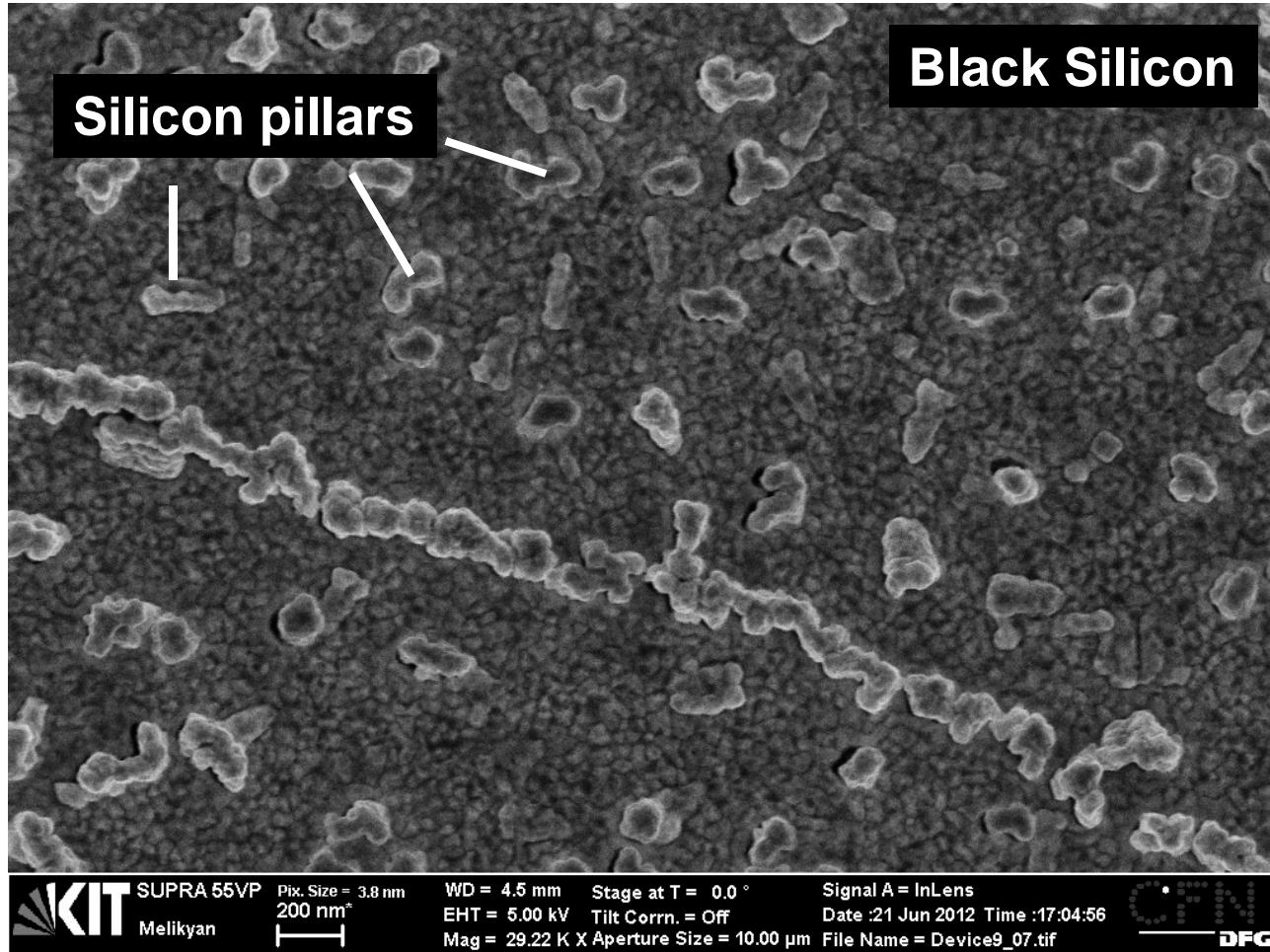
## Design Layout



NAVOLCHI1 at IMEC10 run

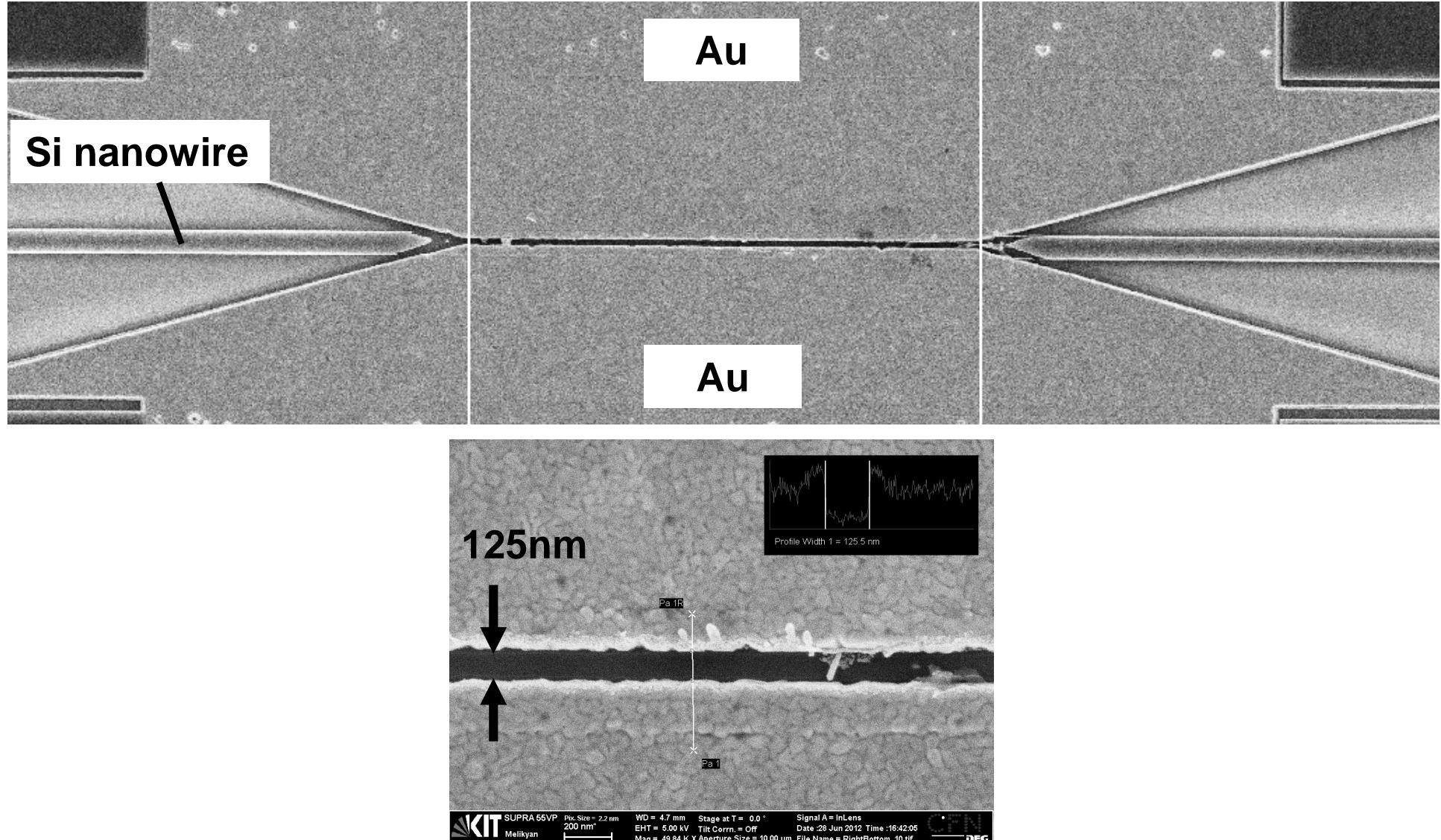


# Silicon Nanowire Etching on NAVOLCHI 1



# Phase Modulator

SEM image of the device



# Next Steps



- Optimizing the Si etching process
- Fabrication of an array of devices on NAVOLCHI 1 chip
- Characterization of propagation losses and coupling losses